## Notice of References Cited Application/Control No. 10/568,704 Examiner Qiuwen Mi Applicant(s)/Patent Under Reexamination BORTLIK ET AL. Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2002/0107292	08-2002	Bortlik et al.	514/773
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	Е	US-			
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